

Title (en)

A METHOD AND APPARATUS FOR PRODUCING MICROCHIPS

Title (de)

VERFAHREN UND VORRICHTUNG ZUM HERSTELLEN VON MIKROCHIPS

Title (fr)

PROCEDE ET APPAREIL DE PRODUCTION DE MICROCIRCUITS

Publication

**EP 1685446 A2 20060802 (EN)**

Application

**EP 04818754 A 20041028**

Priority

- EP 2004012248 W 20041028
- EP 03078487 A 20031105
- EP 04075712 A 20040310
- US 55162904 P 20040310
- EP 04075984 A 20040331
- EP 04077144 A 20040723
- EP 04818754 A 20041028

Abstract (en)

[origin: WO2005050324A2] Method for producing microchips by using immersion lithography, wherein the immersion fluid comprises an additive so that the refractive index of the immersion fluid is increased relative to the fluid not comprising the additive. The exposure light in the method has improved resolution, so that microchips having an increased integration density are obtained. The invention also relates to the immersion fluid and an apparatus for immersion lithography, comprising the immersion fluid.

IPC 8 full level

**G03F 7/20** (2006.01); **H01L 21/47** (2006.01)

CPC (source: EP US)

**G03F 7/2041** (2013.01 - EP US)

Citation (search report)

See references of WO 2005050324A2

Designated contracting state (EPC)

AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HU IE IT LI LU MC NL PL PT RO SE SI SK TR

DOCDB simple family (publication)

**WO 2005050324 A2 20050602; WO 2005050324 A3 20050922**; EP 1685446 A2 20060802; JP 2007525824 A 20070906; TW 200520077 A 20050616; US 2007105050 A1 20070510

DOCDB simple family (application)

**EP 2004012248 W 20041028**; EP 04818754 A 20041028; JP 2006538712 A 20041028; TW 93133521 A 20041103; US 57826504 A 20041028